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**PATENT**  
**29925/39486**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application of: Eun-Young Chung

Serial No.: 10/615,045

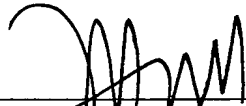
Filed: July 8, 2003

For: Method for Forming  
Semiconductor Device

Group Art Unit: 2829

Examiner: Evan T. Pert

) I hereby certify that this paper and the  
) documents referred to as enclosed  
) therewith are being deposited with the  
) United States Postal Service as first class  
) mail, postage prepaid, on **September 30,**  
) **2004**, in an envelope addressed to  
) Commissioner for Patents, P.O. Box  
) 1450, Alexandria, Virginia 22313-1450

)   
) Michael R. Hull  
) Reg. No. 35,902  
) Attorney for Applicants

**COMMENT ON STATEMENT OF REASONS FOR ALLOWANCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:


In addition to the reasons for allowance set forth in the allowance papers that were mailed in connection with the present application, it is respectfully submitted that the claims are allowable for the additional reasons that the invention defined by the language of the claims is neither anticipated by, nor would have been obvious when taken as a whole in view of, the art of record.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP  
6300 Sears Tower  
233 South Wacker Drive  
Chicago, Illinois 60606-6357  
(312) 474-9577

September 30, 2004

By:

  
Michael R. Hull  
Reg. No. 35,902